



931-2614
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Youichi Itaki, et al.

Examiner: Brian Yenke

Serial No: 09/818,720

Art Unit: 2614

Filed: March 27, 2001

Docket: 14444

For: DISPLAY CONTROL METHOD FOR VIDEO
DISPLAY SYSTEM AND VIDEO
DISPLAY SYSTEM

Dated: November 12, 2004

Confirmation No.: 1334

Mailstop Issue Fees
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

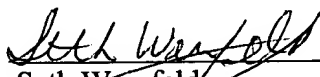
In accordance with 37 C.F.R §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

1. Japanese Patent Application No. 11-148007 (Japanese Laid Open Patent Application 2000-338941 dated December 8, 2000 corresponding to U.S. 2001/0013843 dated August 16, 2001 previously cited by the Examiner in an Office Action dated February 17, 2004.)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 12, 2004

Dated: November 12, 2003

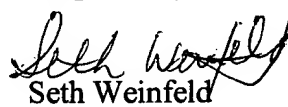

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2. Japanese Laid Open Patent Application 5-145866 dated June 11, 1993
3. Japanese Laid Open Patent Application 10-243322 dated September 11, 1998
4. Japanese Laid Open Patent Application 2000-20042 dated January 21, 2000
5. Japanese Patent Application No. 11-78358 (Japanese Laid Open Patent Application 2000-276099 dated October 6, 2000)
6. Japanese Patent Application No. 11-264572 (Japanese Laid Open Patent Application 2001-92408 dated April 6, 2001 together with English language abstract)
7. Japanese Patent Application No. 10-257000 (Japanese Laid Open Patent Application 2000-92408 dated March 31, 2000 together with English language abstract)
8. Japanese Patent Application No. 2000-85713 (Japanese Laid Open Patent Application 2001-272723 dated October 5, 2001)

The references were cited in an Office Action dated July 15, 2003 received from the Japanese Patent Office. Applicants are submitting copies of the above-cited references, together with an English translation of the Examiner's comments regarding the references from the Official Action. Please note that Japanese Laid Open Patent Application 8-88820 was previously submitted in an Information Disclosure Statement dated March 27, 2001. The relevance of the references is described in the Official Action.

In compliance with the requirements of 37 C.F.R. §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 37 C.F.R. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made; the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

Respectfully submitted,



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Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV. 7-80) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION <div style="border: 1px solid black; border-radius: 50%; padding: 10px; display: inline-block; text-align: center;"> PATENT & TRADEMARK OFFICE NOV 15 2004 3024 301 </div>		Atty. Docket No. (Optional) 14444	Application Number 09/818,720				
		Applicant(s) Youichi Itaki, et. al.					
		Filing Date March 27, 2001	Group Art Unit 2614				
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL*		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (if appropriate)
FOREIGN PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
		2000-338941	8/12/2000	Japan			YES NO
		5-145866	6/11/1993	Japan			
		10-243322	9/11/1998	Japan			
		2000-20042	1/21/2000	Japan			
		2000-276099	10/6/2000	Japan			
		2001-092408	4/6/2001	Japan			
		2000-092408	3/21/2000	Japan			
		2001-272723	5/10/2001	Japan			
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER				DATE CONSIDERED			
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							